

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Young Ho BAE	Conf.:	3483
Appl No:	10/029,035	Art Unit:	1792
Filed:	December 28, 2001	Examiner:	R. N. KACKAR
For:	VACUUM DEPOSITION APPARATUS		

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated November 16, 2007, please amend this application as follows.

This paper includes:

**Amendments to the Specification;**

**Amendments to the Drawings;**

**Amendments to the Claims; and**

**Remarks/Arguments.**